



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul A. Farrar et al. Examiner: C Everhart
Serial No.: 09/945536 Group Art Unit: 2825
Filed: August 30, 2001 Docket No.: 303.469US3
Title: THERMAL PROCESSING OF METAL ALLOYS FOR AN IMPROVED CMP
PROCESS IN INTEGRATED CIRCUIT FABRICATION

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicant has reviewed the Office Action mailed on August 21, 2003. Please amend the above-identified patent application as follows.

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a one-month extension of the period for responding to the Office action, thereby moving the deadline for response from November 21, 2003 to December 21, 2003.

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